

Chemical etching of Cu₂ZnSn(S,Se)₄ monograin powder

Timmo, Kristi; Altosaar, Mare; Raudoja, Jaan; Grossberg, Maarja; Danilson, Mati; Volobujeva, Olga; Mellikov, Enn 35th IEEE Photovoltaic Specialists Conference : Honolulu, HI, June 20-25, 2010 : conference proceedings 2010 / p. 1982-1985 : ill

ZnO grown by chemical solution deposition

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